

## CLAIMS

We Claim:

- 1        1. A method for monitoring a laser signal comprising:
  - 2            (a) forwarding the laser signal to an etalon;
  - 3            (b) detecting light transmitted through the etalon;
  - 4            (c) detecting light reflected from the etalon; and,
  - 5            (d) calculating a ratio from the detected light transmitted through the
  - 6        etalon and the light reflected from the etalon.

- 1        2. A method as in claim 1 wherein in (d) the ratio is equal to power of the
- 2        light transmitted through the etalon divided by power of the light reflected
- 3        from the etalon.

- 1        3. A method as in claim 1 wherein in (d) the ratio is equal to power of the
- 2        light reflected from the etalon divided by power of the light transmitted
- 3        through the etalon.

- 1        4. A method as in claim 1 wherein in (d) the ratio is represented below:

$$\frac{P_t[\lambda]}{P_r[\lambda]} = \frac{T}{R} \frac{1}{FSin^2\left[\frac{2\pi ndCos(\theta)}{\lambda}\right]}$$

- 2        where  $P_t[\lambda]$  represents detected power of the light transmitted through the
- 3        etalon,  $P_r[\lambda]$  represents detected power of the light reflected from the etalon, T
- 4        represents transmittance of the etalon, R represents reflectance of the etalon, F is

6 a coefficient of finesse of the etalon, n is an index of refraction inside a cavity of  
 7 the etalon, d is a cavity length, θ is an angle at which an incident beam passes  
 8 through the cavity, and λ is a wavelength of the laser signal.

1        5. A method as in claim 1 wherein in (d) the ratio is represented below:

$$2 \quad \frac{P_r[\lambda]}{P_t[\lambda]} = \frac{R}{T} F \sin^2 \left[ \frac{2\pi n d \cos(\theta)}{\lambda} \right]$$

3 where  $P_t[\lambda]$  represents detected power of the light transmitted through the  
 4 etalon,  $P_r[\lambda]$  represents detected power of the light reflected from the etalon, T  
 5 represents transmittance of the etalon, R represents reflectance of the etalon, F is  
 6 a coefficient of finesse of the etalon, n is an index of refraction inside a cavity of  
 7 the etalon, d is a cavity length, θ is an angle at which an incident beam passes  
 8 through the cavity, and λ is a wavelength of the laser signal.

1        6. A method as in claim 1 wherein the etalon is a Fabry-Perot etalon.

1        7. A system that monitors a laser signal, the system comprising:  
 2            an etalon that receives the laser signal;  
 3            a first detector that detects light transmitted through the etalon;  
 4            a second detector that detects light reflected from the etalon; and,  
 5            a monitor that calculates a ratio from the detected light transmitted  
 6            through the etalon and the light reflected from the etalon.

1           8. A system as in claim 7 wherein in the ratio is equal to power of the  
 2 light transmitted through the etalon divided by power of the light reflected  
 3 from the etalon.

1           9. A system as in claim 7 wherein the ratio is equal to power of the light  
 2 reflected from the etalon divided by power of the light transmitted through the  
 3 etalon.

1           10. A system as in claim 7 wherein the ratio is represented below:

$$\frac{P_t[\lambda]}{P_r[\lambda]} = \frac{T}{R} \frac{1}{FSin^2\left[\frac{2\pi n d Cos(\theta)}{\lambda}\right]}$$

3 where  $P_t[\lambda]$  represents detected power of the light transmitted through the  
 4 etalon,  $P_r[\lambda]$  represents detected power of the light reflected from the etalon, T  
 5 represents transmittance of the etalon, R represents reflectance of the etalon, F is  
 6 a coefficient of finesse of the etalon, n is an index of refraction inside a cavity of  
 7 the etalon, d is a cavity length,  $\theta$  is an angle at which an incident beam passes  
 8 through the cavity, and  $\lambda$  is a wavelength of the laser signal.

1           11. A system as in claim 7 wherein the ratio is represented below:

$$\frac{P_r[\lambda]}{P_t[\lambda]} = \frac{R}{T} FSin^2\left[\frac{2\pi n d Cos(\theta)}{\lambda}\right]$$

3 where  $P_t[\lambda]$  represents detected power of the light transmitted through the  
 4 etalon,  $P_r[\lambda]$  represents detected power of the light reflected from the etalon, T

5 represents transmittance of the etalon, R represents reflectance of the etalon, F is  
6 a coefficient of finesse of the etalon, n is an index of refraction inside a cavity of  
7 the etalon, d is a cavity length,  $\theta$  is an angle at which an incident beam passes  
8 through the cavity, and  $\lambda$  is a wavelength of the laser signal.

1       12. A system as in claim 7 wherein the etalon is a Fabry-Perot etalon.

1       13. A system as in claim 7 wherein the system additionally comprises:  
2           a reference device that receives the laser signal; and,  
3           a detector that detects light transmitted through the reference device.

1       14. A system as in claim 13 wherein the reference device is a gas cell.

1       15. A system as in claim 13 wherein the monitor uses a ratio  
2           equal to power of the light transmitted through the etalon divided by power of  
3           the light reflected from the etalon to compare the etalon with the reference  
4           device.

1       16. A system as in claim 13 wherein the monitor uses a ratio  
2           equal to power of the light transmitted through the etalon divided by power of  
3           the light reflected from the etalon to compare the etalon with the reference  
4           device and the monitor uses a ratio equal to power of the light reflected from

5 the etalon divided by power of the light transmitted through the etalon to  
6 interpolate between peaks.

1           17. A system that monitors a laser signal, the system comprising:  
2           a measurement means for receiving the laser signal;  
3           a first detection means for detecting light transmitted through the  
4           measurement means;  
5           a second detector means for detecting light reflected from the  
6           measurement means; and,  
7           a device means for calculating a ratio from the detected light transmitted  
8           through the measurement means and the light reflected from the measurement  
9           means.

1           18. A system as in claim 17 wherein in the ratio is equal to power of the  
2           light transmitted through the measurement means divided by power of the light  
3           reflected from the measurement means.

1           19. A system as in claim 17 wherein the ratio is equal to power of the  
2           light reflected from the measurement means divided by power of the light  
3           transmitted through the measurement means.

1           20. A system as in claim 17 wherein the system additionally comprises:  
2           reference means for receiving the laser signal; and,

3           a third detector means for detecting light transmitted through the  
4   reference device.